

00862.023171

PATENT APPLICATION

DFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	)	
TAKASHI ARAI	:	Examiner: Not Yet Assigned
Application No.: 10/634,860	)	
	:	Group Art Unit: 1731
Filed: August 6, 2003	)	
	:	
For: METHOD OF STORING	)	
MATERIAL INTO WHICH GAS	:	
SATURATES	)	November 30, 2005

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

THIRD INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the documents listed on the enclosed Form PTO-1449. Copies of the listed documents are enclosed.

This Information Disclosure Document is to make of record documents cited in a Japanese Office Action issued on September 5, 2005 in the priority application. A copy of the Office Action is also enclosed. In that connection, Applicant notes that the last four documents listed on the attached Form PTO-1449 were listed in the prior art search made by the Japanese Examiner and were applied in a rejection.

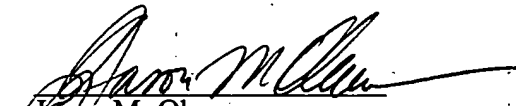
The concise explanation of relevance for the non-English language documents may be found, inter alia, in the English language abstracts attached thereto.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Jason M. Okun  
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